

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In Re Application of )  
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Shunpei Yamazaki et al. )  
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                          )  
Serial No.: 09/544,801 )  
                          )  
                          )  
Filed: April 7, 2000 )  
                          )  
                          )  
For: Semiconductor Device And Method )  
    For Fabricating The Same         )  
                          )  
Art Unit: 2826                  )  
                          )  
Confirmation No.: 1717            )  
                          )  
Examiner: Fazli Erdem            )

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**AMENDMENT (J) AFTER ALLOWANCE**

Sir:

In furtherance of the Notice of Allowance of October 10, 2007, please amend the above-identified application as follows: